



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 10, 2026	
IGI Report Number	LG826665822
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	10.80 X 7.38 X 4.91 MM

GRADING RESULTS

Carat Weight	3.70 CARATS
Color Grade	F
Clarity Grade	VS 2

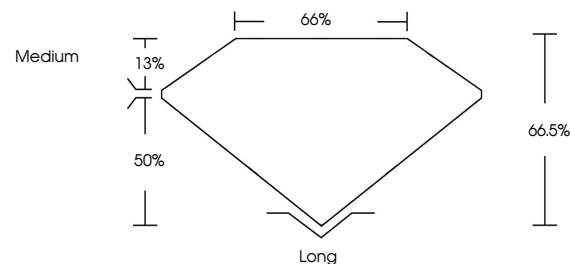
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG82665822

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

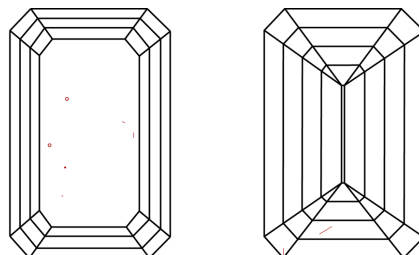
LG826665822
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

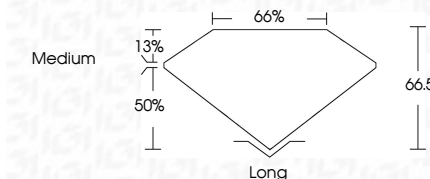
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www.igi.org

August 10, 2026
GI Report No LG826665822

10.80 X 7.38 X 4.91 MM	Color Grade	Clarity Grade	Cut	Polish	Symmetry	Fluorescence
3.70 CARATS	F	VS 2	Long	EXCELLENT	EXCELLENT	NONE
		66.5%				
		66%				
		Medium				

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.